

02-25-02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Jerome M. Eldridge et al.

Title: ATOMIC LAYER DEPOSITION OF METAL OXIDE AND/OR LOW ASYMMETRICAL TUNNEL
BARRIER INTERPOLY INSULATORS

Attorney Docket No.: 1303.045US1

PATENT APPLICATION TRANSMITTAL**BOX PATENT APPLICATION**Commissioner for Patents
Washington, D.C. 20231

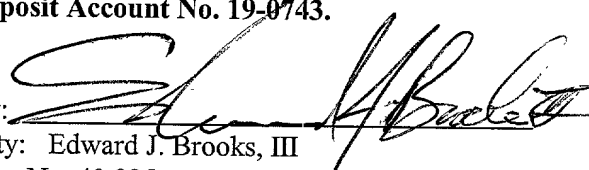
We are transmitting herewith the following attached items and information (as indicated with an "X"):

☒ Return postcard.☒ **CONTINUATION-IN-PART (CIP)** of prior Patent Application No. 09/943,134 (under 37 CFR § 1.53(b))
comprising:☒ Specification (55 pgs, including claims numbered 1 through 84 and a 1 page Abstract).☒ Formal Drawing(s) (16 sheets).☒ **Signed Declaration** (9 pgs).☒ Signed Power of Attorney (1 pg.)☒ Check in the amount of \$2,564.00 to pay the filing fee.☒ Assignment of the invention to Micron Technology, Inc. (10 pgs) and Recordation Form Cover Sheet.☒ Check in the amount of \$40.00 to pay the Assignment recording fee.

The filing fee has been calculated below as follows:

	No. Filed	No. Extra	Rate	Fee
TOTAL CLAIMS	84 - 20 =	64	x 18 =	\$1,152.00
INDEPENDENT CLAIMS	11 - 3 =	8	x 84 =	\$672.00
[] MULTIPLE DEPENDENT CLAIMS PRESENTED				\$0.00
BASIC FEE				\$740.00
TOTAL				\$2,564.00

Please charge any additional required fees or credit overpayment to Deposit Account No. 19-9743.

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Reg. No. 40,925"Express Mail" mailing label number: EV041074569USDate of Deposit: February 20, 2002This paper or fee is being deposited on the date indicated above with the United States Postal Service pursuant to 37 CFR 1.10, and is addressed to
The Commissioner for Patents, Box Patent Application, Washington, D.C. 20231.